

SA201 Series

Clean Room Robot for Semiconductor



- 絕對型伺服驅動
Drive by absolute servo motor
- 高速度、高性能
High Speed、High Performance
- 高潔淨度晶圓搬送用
Super clean for wafer handling
- SEMI S2-0715 **CE**
APPROVED

Specification

Item		Specification
Operating Range	Theta-Axis	-60~280 deg
	Z-Axis	0~300 mm
	R/L-Axis (ARM)	0~515 mm
Maximum Speed	Theta-Axis	500 deg/s
	Z-Axis	400 mm/s
	R/L-Axis (ARM)	1000 mm/s
Repeatability		±0.1 mm
Cleanliness		Below ISO 2
Approx. Mass		50 kg
Utility		Power AC220 V ±10% 2.5A
		Vacuum -73~-100 kPa 100 L/min
Payload Capacity		Below 3 kgf

Dimensions

